In re Application of: WILFRIED ENSINGER

Application No. Filed:

10/814,587 April 1, 2004

For:

RETAINING RING FOR HOLDING SEMICONDUCTOR WAFERS IN A CHEMICAL MECHANICAL

POLISHING APPARATUS

U.S. Patent and Trademark Office Randolph Building 401 Dulany Street

Ale	xandria, VA 22314
Sir:	
	Small entity status is claimed for this application under 37 CFR 1.27.
\boxtimes	Petition for an extension of time for the period noted below, as well as for any additional period necessary to render the present submission timely. Please charge Deposit Account No. 12-1216 for the appropriate petition fee.
	Other:
\boxtimes	Please charge Deposit Account No. 12-1216 in the total amount indicated below. (A duplicate copy of this communication is enclosed for that purpose, unless submitted via EFS-Web.)

					SMALL ENTITY \$ 0.00		OTHER THAN A SMALL ENTITY \$1,050.00	
TIME EXTENSION PETITION FEE			three-month					
	subtract time extension fee previously paid		none		(\$ 0.00)		(\$ 0.00)	
CLAIM FEE	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	RATE	ADD'L CLAIM FEE	RATE	ADD'L CLAIM FEE
Total		Minus		=	x 25 =	\$	x 50 =	\$
INDEPENDENT		Minus		=	x 105 =	\$	x 210 =	\$
☐ FIRST PRE	FIRST PRESENTATION OF MULTIPLE CLAIM					\$	+ 370 =	\$
TOTAL AMOUNT TO BE CHARGED TO DEPOSIT ACCOUNT					TOTAL	\$	TOTAL	\$1,050.00

The Commissioner is hereby authorized to charge any deficiencies in the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-1216. (A duplicate copy of this communication is enclosed for that purpose, unless submitted via EFS-Web.)

Any filing fees under 37 CFR 1.16 for the presentation of extra claims.

Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

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Date: 11 Dec. 2007